

2823



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PATENT

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Case Docket No.: 99 P 7722 US (8055-98)Date: September 18, 2002

ASSISTANT COMMISSIONER FOR PATENTS
Washington, D.C. 20231
Box PATENT APPLICATION

Sir:

Transmitted herewith is an amendment in the identified application noted below.

☒ No additional fee is required.

In re application of: Jammy et al.Serial No.: 09/363,523Filed: July 29, 1999For: METHOD FOR FORMING CRYSTALLINE SILICON NITRIDE

The filing fee has been calculated as shown below:

| | (Col. 1) | (Col. 2) | (Col. 3) | OTHER THAN A SMALL ENTITY FEE | |
|--|-------------------------------------|---------------------------------------|------------------|-------------------------------------|---------------|
| CLAIMS | CLAIMS REMAINING AFTER AMENDMENT | HIGHEST NO. PREVIOUSLY PAID FOR | PRESENT EXTRA | RATE | ADDIT. FEE |
| TOTAL | 20 | MINUS 20 | = 0 x = | \$ 0 | |
| INDEP | 3 | MINUS 3 | = 0 x = | \$ 0 | |
| FIRST PRESENTATION OF MULTIPLE DEPENDENT CLAIM | | | | + 280 = | \$ 0 |
| TOTAL | | | | | \$ 0 |

☒ Please charge my Deposit Account No. 19-2179 in the amount of \$.00

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☒ The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 19-2179.

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☒ Any additional filing fees required under 37 CFR 1.16 for the presentation of excess claims.

☒ Any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

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Date: September 18, 2002

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Attorney Docket: 8055-98 (99-P-7722-US)
PATENT

#19/Response
OK
10/9/02



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jammy et al.

Examiner: Estrada, Michelle

Serial No: 09/363,523

Group Art Unit: 2823

Filed: July 29, 1999

Docket: 8055-98 (99-P-7722-US)

For: **METHOD FOR FORMING CRYSTALLINE SILICON NITRIDE**

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

RESPONSE

This is a response to the office action mailed on June 18, 2002. Please consider the following remarks.

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CERTIFICATE OF MAILING 37 C.F.R. § 1.8(a)

I hereby certify that this correspondence (and any document referred to as being attached or enclosed) is being deposited with the United States Postal Service as first class mail, postage paid in an envelope addressed to: Director of the U.S. Patent and Trademark Office, Washington, D.C. 20231 on September 18, 2002.

Dated: 9/18/02


Frank DeRosa